#### MYERS BIGEL SIBLEY & SAJOVEC

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# **MESSAGE**

Comments: Copy of Request for Corrected Filing Receipt and Petition to Accord the Proper Filing Date, evidence of filing date, and stamped return postcard

In re: Gi-Jung Kim et al. (Attorney Docket No. 5649-921)

USSN 10/601,475 Filed June 23, 2003

SEMICONDUCTOR WAFERS HAVING ASYMMETRIC EDGE PROFILES

THAT FACILITATE HIGH YIELD PROCESSING BY INHIBITING

PARTICULATE CONTAMINATION AND METHODS OF FORMING SAME

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OCT 28 2003

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5649-921 October 21, 2003

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Sir: Kindly acknowledge receipt of the accompanying by placing your receiving date stamp hereon and mailing:

Request for Corrected Filing Receipt and Petition to Accord the Proper Filing Date; Copy of Filing Receipt with Changes Shown in Red; Copy of Cover Sheet of Application; Express Mail Receipt; Track & Confirm Web Page; Stamped Return Postcard showing July 23, 2003 as Correct Filing Date; In re: Gi-Jung Kim et al.; Serial No. 10/601,475; Filed June 23, 2003; For: SEMICONDUCTOR WAFERS HAVING ASYMMETRIC EDGE PROFILES THAT FACILITATE HIGH YIELD PROCESSING BY INHIBITING PARTICULATE CONTAMINATION AND METHODS OF FORMING SAME

Respectfully submitted,
MYERS BIGEL SIBLEY & SAJOVEC

5649-921 October 21, 2003

Office of Patent Legal Administration Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Kindly acknowledge receipt of the accompanying placing your receiving date stamp hereon and mailing:

Request for Corrected Filing Receipt and Petition to Accord the Proper Filing Date; Copy of Filing Receipt with Changes Shown in Red; Copy of Cover Sheet of Application; Express Mail Receipt; Track & Confirm Web Page; Stamped Return Postcard showing July 23, 2003 as Correct Filing Date; In re: Gi-Jung Kim et al.; Serial No. 10/601,475; Filed June 23, 2003; For: SEMICONDUCTOR WAFERS HAVING ASYMMETRIC EDGE PROFILES THAT FACILITATE HIGH YIELD PROCESSING BY INHIBITING PARTICULATE CONTAMINATION AND METHODS OF FORMING SAME

Respectfully submitted,
MYERS BIGEL SIBLEY & SAJOVEC

Attorney Docket No. 5649-921

PATENT

#### IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re: Gi-Jung Kim et al. Serial No.: 10/601,475 Filed: June 23, 2003 Group Art Unit: 2811 Examiner: To be assigned Confirmation No.: 7249

For SEMICONIT

SEMICONDUCTOR WAFERS HAVING ASYMMETRIC EDGE PROFILES THAT FACILITATE HIGH YIELD PROCESSING BY INHIBITING PARTICULATE

CONTAMINATION AND METHODS OF FORMING SAME

**FAX RECEIVED** 

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PETITIONS OFFICE

# REQUEST FOR CORRECTED FILING RECEIPT AND PETITION TO ACCORD THE PROPER FILING DATE

Sir:

In reviewing the Official Filing Receipt (copy attached), Applicants note that inventor Sang-Mun Chon's name incorrectly appears as Sang-Mung Chon in the above-referenced application. Applicants respectfully request that inventor Chon's name be corrected to read Sang-Mun Chon and that a corrected Filing Receipt be issued.

As set forth in 37 CFR § 1.10(c) and MPEP § 506.02, Applicants hereby petition to grant the proper filing date of <u>June 23, 2003</u> rather than <u>June 24, 2003</u> as this was the date the application was deposited as "Express Mail" in the U.S. Postal Service. The following is enclosed as evidence of June 23, 2003 being the correct filing date for the application, which was properly filed under 37 C.F.R. § 1.10:

- 1. A true and accurate copy of the Cover Sheet for the Application showing the Express Mail signature and date on Page 2;
- 2. A true and accurate copy of the Express Mail Receipt along with a copy of the USPS-Track & Confirm from the web page, showing "acceptance" or deposit date with the USPS at 5:39 p.m. on June 23, 2003; and
- 3. A true and accurate copy of our return post card and of the official filing receipt for this application, sent by the United States Patent and Trademark Office, showing that Applicants were improperly given the filing date of June 24, 2003 instead of the Express Mail date of June 23, 2003.

In re: Gi-Jung Kim et al. Serial No.: 10/601,475

Page 2

This petition is being filed promptly after Applicants became aware of the improperly accorded filing date. Accordingly, Applicants respectfully request the granting of June 23, 2003 as the filing date pursuant to 37 CFR § 1.10.

On the basis that Applicants properly followed the requirements of 37 CFR § 1.10 and the USPTO failed to accord the proper filing date under MPEP § 505 and thus the need to file this petition is due to error on the part of the USPTO, it is Applicant's belief that no fee is due with this petition. However, the Commissioner is authorized to charge any deficiency or credit any overpayment to Deposit Account No. 50-0220.

Respectfully submitted

Attorney For Applicants Registration No. 36,925

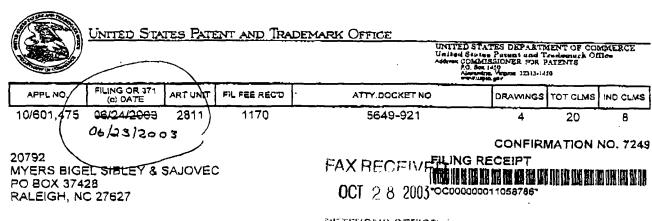
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#### Certificate of Mailing under 37 CFR 1.8

I hereby certify that this correspondence is being deposited with the United States Postal Service with sufficient postage as first class mail in an envelope addressed to: Office of Patent Legal Administration, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450 on October 22, 2003.

Candi L. Riggs ()()
Date of Signature: October 22, 2003



PETITIONS OFFICE

Date Mailed: 10/17/2003

Receipt is acknowledged of this regular Patent Application. It will be considered in its order and you will be notified as to the results of the examination. Be sure to provide the U.S. APPLICATION NUMBER, FILING DATE, NAME OF APPLICANT, and TITLE OF INVENTION when inquiring about this application. Fees transmitted by check or draft are subject to collection. Please verify the accuracy of the data presented on this receipt. If an error is noted on this Filing Receipt, please write to the Office of Initial Patent Examination's Filing Receipt Corrections, facsimile number 703-746-9195. Please provide a copy of this Filing Receipt with the changes noted thereon. If you received a "Notice to File Missing Parts" for this application, please submit any corrections to this Filing Receipt with your reply to the Notice. When the USPTO processes the reply to the Notice, the USPTO will generate another Filing Receipt incorporating the requested corrections (if appropriate).

Applicant(s)

Gi-Jung Kim, Kyeonkgi-do, KOREA, REPUBLIC OF; Woo-Serk Kim, Kyeongki-do, KOREA, REPUBLIC OF; Sang-Muny Chon, Kyeongki-do, KOREA, REPUBLIC OF; Tae-Yeol Heo, Kyeongki-do, KOREA, REPUBLIC OF;

Domestic Priority data as claimed by applicant

This appln claims benefit of 60/407,516 08/29/2002

Foreign Applications

If Required, Foreign Filing License Granted: 10/17/2003

Projected Publication Date: 03/04/2004

Non-Publication Request: No

Early Publication Request: No

40-20-93 609:53 13

Title

Semiconductor wafers having asymmetric edge profiles that facilitate high yield processing by inhibiting particulate contamination and methods of forming same

Preliminary Class

257

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#### NOT GRANTED

No license under 35 U.S.C. 184 has been granted at this time, if the phrase "IF REQUIRED, FOREIGN FILING LICENSE GRANTED" DOES NOT appear on this form. Applicant may still petition for a license under 37 CFR 5.12, if a license is desired before the expiration of 6 months from the filing date of the application. If 6 months has lapsed from the filing date of this application and the licensee has not received any indication of a secrecy order under 35 U.S.C. 181, the licensee may foreign file the application pursuant to 37 CFR 5.15(b).

PATENT

### IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

ATTY DOCKET NO.: 5649-921 DATE: June 23, 2003

# UTILITY PATENT APPLICATION TRANSMITTAL LETTER AND FEE TRANSMITTAL FORM (37 CFR 1.53(b))

Mail Stop PA Commissione P.O. Box 145 Alexandria, V	FAX RECEIVED OCT 2 8 2003	
Sir:		PETITIONS OFFICE
a patent a a Continu application incorpora	herewith for filing under 37 CFR 1.53(b) is: application uation a Divisional a Continuation-in-Part (CIP) on no.:; filed, the ated herein by reference in its entirety. as the benefit of Provisional Application No. 60/407,516; filed a	ne disclosure of which is hereby
Inventor(s) o	r Application Identifier:	
Woo-Serk K Sang-Mun C	n – Kyeongki-do, Republic of Korea Kim – Kyeongki-do, Republic of Korea Chon – Kyeonki-do, Republic of Korea eo – Kyeongki-do, Republic of Korea SEMICONDUCTOR WAFERS HAVING ASYMMETRI	IC EDGE PROFILES THAT
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	Correspondence Address:	
•	20792 PATENT TRADEMARK OFFICE	,
2.	ication Transmittal Letter and Fee Transmittal Form (A duplicate ages of Specification (including 20 claims) ets of Formal Drawings (35 USC 113) or Declaration  I newly executed (original or copy)  I copy from prior application (37 CFR 1.63(d) (for constnuation/divisional DELETION OF INVENTOR(S) (Signed statement deleting inventor(s) in	) (Note Box 6 Below)
6. Incorp	ication Data Sheet. See 37 CFR 1.76  portation By Reference (useable if box 4b is checked)  attre disclosure of the prior application, from which a copy of the oath or dec  b, is considered as being part of the disclosure of the accompanying applicant trence therein.	inntion is supplied under tion and is hereby underporated

8. Assignment pa 9. Applicant clair 10. Information Di 11. Preliminary Ar 12. English Transl 13. Certified Copy	mendment (Please ation Document of Applicancy Sequence List dable copy support Power of Attorney Postcard (MPEP	and document(s)) trus. See 37 CFF it, PTO-1449, ar trenter all claim ation No. ing Diskette  503) (Should be sp	nd 13 references cite amendments prior Filed	FAX RECEINOCT 28 200	/ED 03
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Express Mail Label No. EV Date of Deposit: June 23, Thereby certify that the to Addressee" service unde APPLICATION, Commissi Candi L. Riggs	7 353609701 US 2003 is correspondence is b r 57 CFR 1.10 on the	eing deposited with	e and is addressed to:	al Servics "Express Mail ? Mail Stop PATENT	оят СЩсэ

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- (ACCEPTANCE, June 23, 2003, 5:39 pm, RALEIGH, NC 27612\_

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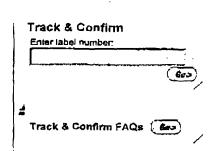


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5649-921 June 23, 2003

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Sir. Kindly acknowledge receipt of the accompanying by placing your receiving date stamp hereon and mailing:

Utility Patent Application Transmittal Letter and Fee Transmittal Form (in duplicate); Specification (12 pages - 20 claims); Drawings (4 sheets - Figures 1-4C); Declaration and Power of Attorney; Assignment Recordation Form Cover Sheet; Assignment; Information Disclosure Statement; Form PTO-1449; Copies of 13 cited references; Check in the amount of \$1,210.00; In re: Kim et al.; For: SEMICONDUCTOR WAFERS HAVION ASSYMETRIC EDGE PROFILES THAT FACILITATE HIGH YIELD PROCESSING BY INHIBITING PARTICULATE OF CONTACTION AND METHODS OF FORMING SAME

07-10-03 AD9:13 IN

Respectfully submined,
MYERS BIGEL SIBLEY & SAJOVEC



MYERS BIGEL SIBLEY & SAJOVEC, PA Patent Lawyers PO. Box 37428 Raleigh, NC 27627 U.S.A.

18846 U.S. PTO 10/601475